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PATENT

Attorney Docket No. MTI-31532

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Weimer, Ronald A.
 Serial No.: 09/941,827
 Filing Date: August 29, 2001
 For: Method of Improved High K Dielectric-Polysilicon Interface for CMOS Devices
 Examiner: HUYNH, Yennhu B.
 Group Art Unit: 2813
 Confirmation No.: 7551

CERTIFICATION UNDER 37 CFR 1.8(a) and 1.10
 I hereby certify that, on the date shown below, this correspondence is being transmitted to Fax No. 571-273-8300
 addressed to Examiner HUYNH at the US Patent and Trademark Office.

Date: 9-1-05

Kisa Chandler

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

RESPONSE

Sir:

Applicant requests consideration of the pending claims in the above-identified patent application based on the remarks herein.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 29 of this paper.